

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Eran Dvir, Eli Haimovich, and Benjamin Shulman

Assignee: Nova Measuring Instruments, Ltd.

Title: APPARATUS FOR OPTICAL INSPECTION OF WAFERS DURING POLISHING

Serial No.: 08/497,382

Filed: June 29, 1995

Examiner: E. Morgan

Group Art Unit: 3203

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San Jose, California
February 17, 1998

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COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, D. C. 20231

AMENDMENT UNDER 37 C.F.R. § 1.312(a)

Dear Sir:

Pursuant to 37 C.F.R. §1.312(a) kindly amend the above-identified application as follows:

IN THE DRAWINGS

Applicants request permission to amend drawing Figures 6, 7, 8, and 9 as submitted with changes as marked up in red ink accompanying the Request to Amend Drawings Under 37 C.F.R. § 1.123. A new set of formal drawings comprising Figures 1-13 is provided which incorporates the changes to Figures 6, 7, 8 and 9 and overcomes the objections raised in the Notice of Draftsperson's Patent Drawing Review.

IN THE SPECIFICATION

Page 2, line 2, kindly change "is produced found in" to --is--;

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